	18MTOE02	SURFACE ENGINEERING	L	Т	P	С
			3	0	0	3
Course Ob	ojectives:					
1. Analyz	re the various concepts o	f surface engineering and comprehend the design o	lifficulti	es		
UNIT I	TRIBOLOGY AND PLA	ATING PROCESSES		9	+	0
wear, roles electrodepo plating adh	of friction and lubrication osition, plating of nickel, o	es of wear - adhesive, abrasive, oxidative, corrosive and wear testing. Plating Processes: Fundamental chromium, tin and copper, pulsed plating, hydrogen , electrochemical conversion coating, selective plati	s of embrit	tleme	ent,	
UNIT II	HARD FACING PROC	FSSES		9	+	0
		W, PAW, Oxy-Acetylene Welding, Furnace fusing,	Therm:		-	
LINIT III	SPECIAL DIFFUSION	PROCESSES		9	+	0
	<ul> <li>Characteristics of diffus</li> </ul>	PROCESSES riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evaluations.				<b>0</b>
Principle of processes	l f diffusion processes - Bo - Characteristics of diffus	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evalu		diffu	sion	
Principle of processes and applica  UNIT IV  Physical varapour dep	f diffusion processes - Bo - Characteristics of diffus ations.  THIN FILM COATINGS apour deposition processes	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evalu	iation -	diffu prop 9	sion perties +	s 0
Principle of processes and applica  UNIT IV  Physical varapour dep	r diffusion processes - Bo - Characteristics of diffuses ations.  THIN FILM COATINGS apour deposition processes aposition - reactive sputteriand applications.	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evaluates  Ses - Thermal evaporation - sputter coating - Ion plat	iation -	diffu prop 9	sion perties +	s 0
UNIT IV Physical va vapour dep properties a  UNIT V  Electron be created by	THIN FILM COATINGS apour deposition processes osition - reactive sputteriand applications.  HIGH ENERGY MODIFIERM hardening, glazing, Laser and Electron beam	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evaluates  Ses - Thermal evaporation - sputter coating - Ion plating - TiC, TiN, Alumina, CBN, Diamond and DLC co	ing - Catings.	9 heminal Strue	+ ical cture + ace carbic	s 0
UNIT IV Physical va vapour dep properties a  UNIT V  Electron be created by	THIN FILM COATINGS apour deposition processes osition - reactive sputteriand applications.  HIGH ENERGY MODIFIERM hardening, glazing, Laser and Electron beam	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evaluates - micro structure	ing - Catings.	9 hemi Stru  9 westerd of Westerd	+ ical cture  + ace carbicar plat	o o de de des.
UNIT IV Physical va vapour dep properties a  UNIT V  Electron be created by	THIN FILM COATINGS apour deposition processes and applications.  HIGH ENERGY MODIF earn hardening, glazing, L laser and Electron beam hal / chemical. Ceramic c	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evaluates - micro structure	ing - Catings.	9 hemi Stru  9 westerd of Westerd	+ ical cture  + ace carbicar plat	o o de de des.
Principle of processes and applica  UNIT IV  Physical vavapour deproperties a  UNIT V  Electron becreated by cloth, therm	THIN FILM COATINGS apour deposition processes and applications.  HIGH ENERGY MODIF earn hardening, glazing, L laser and Electron beam hal / chemical. Ceramic c	riding, Aluminising, Siliconising, Chromising - Selected layer - micro structure and micro hardness evaluates - micro hardness evaluates - micro hardness evaluates - micro hardness evaluates - micro structure and micro hardness evaluates -	ing - Catings.	9 hemi Stru  9 westerd of Westerd	+ ical cture  + ace carbicar plat	o o de tes.

CO2	: Explain the various hard facing processes					
CO3	Enhancement of surface properties with diffusion of foreign atoms into the outer surface of the material such as boriding, aluminizing, etc					
CO4	Describe the various vapour deposition processes of different materials on the surface of native materials using the Chemical, Physical and Thermal vapour deposition processes.					
CO5	Describe the Modern processes and high energy processes like electron beam hardening, laser beam hardening.					
Text B	Text Books:					
1.	Chattopadhyay R., Surface Wear: Analysis, Treatment, Prevention, ASM International, USA, 2001					
2.	Kenneth G. Budinski, Surface Engineering for Wear Resistance, Prentice Hall, Englewood Cliff, 1990.					
Reference Books:						
1.	ASM Metals Handbook, Vol 5: Surface Engineering, ASM International, Ohio, 1994.					
2.	Ernest Rabinowicz, Friction and Wear of Materials, 2nd ed., John Wiley & Sons, NY, 1995.					
3.	Davis J.R., Surface Engineering for Corrosion and Wear resistance, ASM International, 2001.					